

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No. 10/074,884  
Confirmation No. 6510

Art Unit: 2826  
Examiner: Fazli Erdem

Title: Semiconductor Topography Including a Thin Oxide-Nitride Stack and Method for Making the Same

I hereby certify that this correspondence is being transmitted to the United States Patent & Trademark Office via electronic submission or facsimile on the date indicated below:

11/20/2007      /Pamela Gerik/  
Date                      Pamela Gerik

**SUPPLEMENTAL AMENDMENT/RESPONSE TO**  
**FINAL OFFICE ACTION MAILED AUGUST 22, 2007**

Dear Sir/Madam:

This paper is submitted as a supplemental response to the final Office Action mailed August 22, 2007 and the subsequent Advisory Action mailed November 7, 2007. The amendment cancels the rejected claims, leaving only the allowed claims as pending in the captioned case.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.